Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/663,903	SASAKI, YOSHITAKA	
Examiner	Art Unit	
Paul D. Kim	3729	

SEARCHED			
Class	Subclass	Date	Examiner
29	603.11 603.13- 603.16 603.18	6/30/2005	PK
360	126 317	6/30/2005	PK
			-

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Reviewed Parent Application 09/708628 (US PAT. 6,657,815)	6/30/2005	PK
Text Search EAST/NPL (IEEE)	6/30/2005	PK